



TFW 2136
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Shinichiro TANIGUCHI et al.

Group Art Unit: 2136

Application No.: 09/454,865

Examiner: C. COLIN

Filed: December 7, 1999

Docket No.: 104934

For: DISTRIBUTION INFORMATION MANAGEMENT SYSTEM AND METHOD

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed more than three months after the U.S. filing date AND after the mailing date of the first Office Action on the merits, but before the mailing date of a Final Rejection, Notice of Allowance or other action that closes prosecution (e.g., Quayle Action).
- ☒ a. Attached is our Check No. 181950 in the amount of \$180.00 in payment of the fee under 37 CFR §1.17(p). Please credit or debit Deposit Account No. 15-0461 as needed to ensure consideration of the disclosed information. Two duplicate copies of this paper are attached.
- ☒ 2. One or more reference cited herein was cited in a counterpart foreign application. An English language version of the foreign Office Action is attached for the Examiner's information. See References 1-4.
- ☒ 3. An English language Abstract of one or more non-English language reference is attached hereto. See References 1-3.

07/13/2006 LWONDIM1 00000061 09454865

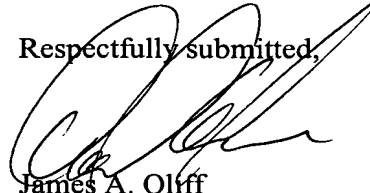
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- ☒ 4. A computer-generated English language translation of one or more Japanese Patent Publication cited herein has been obtained from the website of the Japanese Patent Office ([<http://www.jpo.go.jp>]), and is attached, but has not been reviewed for accuracy. See References 1-3.

Respectfully submitted,



James A. Oliff

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JAO:DAT/cfr

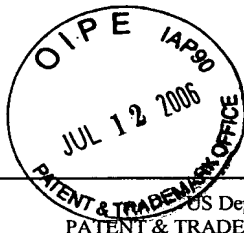
Date: July 12, 2006

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**DEPOSIT ACCOUNT USE
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09/454,865

INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

APPLICANT(S)
Shinichiro TANIGUCHI et al.FILING DATE
December 7, 1999GROUP
2136

U.S. PATENT DOCUMENTS

Examiner Initials	Cite No.	Document Number	Date	Name

FOREIGN PATENT DOCUMENTS

Examiner Initials	Cite No.	Document Number	Date	Country	With English Abstract	With English Translation
	1	JP-A-10-171905	06/26/1998	Japan	X	X
	2	JP-A-11-73461	03/16/1999	Japan	X	X
	3	JP-A-9-261217	10/03/1997	Japan	X	X

OTHER DOCUMENTS

Examiner Initials	Cite No.	(Including Author, Title, Date, Pertinent Pages, etc.)
	4	Hitachi Hyoron, "Next Generation Logistic System Using Non-Contact IC Technology," Vol. 80, 4/4/1998, pp. 35-40.

EXAMINER

DATE CONSIDERED

Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Date: July 12, 2006